

<b>Notice of References Cited</b>	Application/Control No. 10/670,795		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Laura M. Schillinger		Art Unit 2813	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,563,183 B1	05-2003	En et al.	257/410
*	B	US-2004/0110375 A1	06-2004	Chen et al.	438/689
*	C	US-2004/0129674 A1	07-2004	Bease et al.	216/067
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	T	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P	WO 2004109772 A2	12-2004	World Intellect	CHEN et al.	H01L 21/00
	Q	WO 2004109772 A2	12-2004	World Intellect	CHEN et al.	H01L 21/00
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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